



NOTES/SPECIFICATIONS:

- DESIGN WAVELENGTH RANGE: 333-364nm CLEAR APERTURE: > Ø 20.3mm DIAMETER TOLERANCE: $\pm 0.0/-0.1$ mm THICKNESS TOLERANCE: ± 0.2 mm SURFACE QUALITY (S1): 10-5 SCRATCH-DIG SURFACE (S2): FINE GROUND SURFACE FLATNESS (S1): $< \lambda/10$ AT 633nm PARALLELISM: < 3 arcmin 1.

- 2. 3. 4. 5. 6. 7. 8.
- COATING (S1): REFLECTIVE COATING AT 352nm R>99.5%, AOI = 0° 9. Rs>99.0%, Rp>98.7, AOI =45°

FOR INFORMATION ONLY NOT FOR MANUFACTURING PURPOSES

DRAWING PROJECTION					
	NAME	DATE	Ø25.4mm AR-ION LASER LINE		E
DRAWN	GG	10/MAR/16	MIRROR, 333-364nm		
APPROVAL	DD	10/MAR/16	MATERIAL FUSED SILICA		REV
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VALUES IN PARENTHESIS ARE CALCULATED AND MAY CONTAIN ROUNDOFF ERRORS			ITEM # NB1-K07	APPROX WE	IGHT